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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Yasuji HIRAMATSU, et al.

SERIAL NUMBER: 10/070,443

GROUP: 3742

FILED: June 24, 2002

EXAMINER: FUQUA, SHAWNTINA T

FOR: CERAMIC HEATER FOR A SEMICONDUCTOR PRODUCING/EXAMINING DEVICE, PROCESS OF PRODUCING THE CERAMIC HEATER, AND PRODUCTION SYSTEM OF THE CERAMIC HEATER

REQUEST TO CORRECT TITLE OF INVENTION

MAIL STOP ISSUE FEE
COMMISSIONER FOR PATENTS
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SIR:

In the matter of the above-identified application for patent, we hereby request correction of your records to reflect the correct title of the invention. The title of the invention should read as follows: **CERAMIC HEATER FOR A SEMICONDUCTOR PRODUCING/EXAMINING DEVICE, PROCESS OF PRODUCING THE CERAMIC HEATER, AND PRODUCTION SYSTEM OF THE CERAMIC HEATER.**

Respectfully Submitted,

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